

<b>Notice of References Cited</b>	Application/Control No. 10/500,702		Applicant(s)/Patent Under Reexamination TOBITA, YOUICHI	
	Examiner Emmanuel Hailemariam		Art Unit 2629	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0067328	06-2002	YUMOTO et al.	345/92
*	B	US-2004/0252116	12-2004	Tobita, Youichi	345/211
*	C	US-6,034,556	03-2000	Koyasu et al.	327/96
*	D	US-6,980,194	12-2005	Tobita, Youichi	345/100
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.